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MAIL STOP PCT
PATENT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application No.: 10/594,635
Applicant: Yoshiharu OHTA et al.
Filing Date: September 28, 2006
Group Art Unit: Unassigned
Title: SEMICONDUCTOR POLISHING COMPOSITION
Docket No.: 2691-000050/US

REQUEST FOR RECORDATION OF
INTERNATIONAL PRELIMINARY EXAMINATION REPORT

MAIL STOP PCT

December 8, 2006

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Applicant attaches hereto an International Preliminary Examination Report which has been issued in connection with the above-identified application. Please make this document part of the prosecution history of the present application.

Respectfully submitted,

HARNESS, DICKEY & PIERCE, P.L.C.

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Attachment: International Preliminary Examination Report